

MAR 17 2003

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Tomasz L. KLOSOWIAK et al

SERIAL NO: 09 897,059

GROUP ART UNIT: 2814

FILED: July 3, 2001

EXAMINER: Douglas WILLE

FOR: STRUCTURE AND METHOD FOR FABRICATING SEMICONDUCTOR STRUCTURES AND DEVICES UTILIZING THE FORMATION OF A COMPLIANT SUBSTRATE FOR MATERIALS USED TO FORM THE SAME AND PIEZOELECTRIC STRUCTURES HAVING CONTROLLABLE OPTICAL SURFACES

REQUEST FOR EXTENSION OF TIME
UNDER 37 C.F.R. §1.136

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

It is hereby requested that a **four** month extension of time be granted to March 15, 2003 for:

- ☒ filing a response to the Official Action (Restriction Requirement) dated: October 15, 2002
- ☐ responding to the requirements in the Notice of Allowability dated:
- ☐ filing the Formal Drawings. The Issue Fee due has been timely filed.
- ☐ responding to the Notice to File Missing Parts of Application dated:
- ☐ filing a Notice of Appeal. A timely response to the final rejection, due has been filed.
- ☐ filing an Appeal Brief. A Notice of Appeal was filed on:
- ☐ Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.

The required fee of \$1,450.00 is enclosed herewith by check and any further charges may be made against the Attorney of Record's Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

03/20/2003 HLE333 00000005 09897059

01 FC:1254

1450.00 DP

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

Richard L. Treanor

Registration No. 36,379



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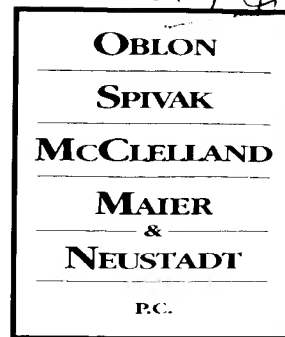
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WASHINGTON, D.C. 20231



ATTORNEYS AT LAW

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RE: Application Serial No.: 09/897,059

Applicants: Tomasz L. KLOSOWIAK et al

Filing Date: July 3, 2001

For: STRUCTURE AND METHOD FOR FABRICATING
SEMICONDUCTOR STRUCTURES AND DEVICES
UTILIZING THE FORMATION OF A COMPLIANT
SUBSTRATE FOR MATERIALS USED TO FORM
THE SAME AND PIEZOELECTRIC STRUCTURES
HAVING CONTROLLABLE OPTICAL SURFACES

Group Art Unit: 2814

Examiner: Douglas WILLE

SIR:

Attached hereto for filing are the following papers:

**REQUEST FOR EXTENSION OF TIME (FOUR MONTH)
RESTRICTION RESPONSE**

Our check in the amount of **\$1,450.00** is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

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